

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Mitsu Ozono *et al.*  
Appln. No. : 10/620,184  
Filed: : July 15, 2003  
Title : METHOD AND APPARATUS FOR PICKING UP SEMICONDUCTOR CHIP AND SUCTION AND EXFOLIATION TOOL USED THEREFOR

Conf. No. : 8698  
TC/A.U. : 1734  
Examiner : Mark A. Osele

Customer No. : 000,116  
Docket No. : 35857

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Sir:

In accordance with 37 CFR § 1.98, Applicant is aware of the publications listed in an Office Action issued on July 11, 2008 during the prosecution of a corresponding Chinese patent application No. 03816665.8 and is submitting herewith Form PTO/SB/08A listing references for consideration by the Examiner. A copy of each listed publication is enclosed.

If there are any fees associated with this communication, please charge said fees to Deposit Account No. 16-0820, Order No. NGB-35857.

Respectfully submitted,

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